

PROCEEDINGS OF SPIE

Emerging Digital Micromirror Device Based Systems and Applications XIV

**John Ehmke
Benjamin L. Lee**
Editors

**22–27 January 2022
San Francisco, California, United States**

**20–24 February 2022
ONLINE**

Cosponsored by
DLP Texas Instruments (United States)
ViALUX GmbH (Germany)

Published by
SPIE

Volume 12014

Proceedings of SPIE 0277-786X, V. 12014

SPIE is an international society advancing an interdisciplinary approach to the science and application of light.

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Author(s), "Title of Paper," in *Emerging Digital Micromirror Device Based Systems and Applications XIV*, edited by John Ehmke, Benjamin L. Lee, Proc. of SPIE 12014, Seven-digit Article CID Number (DD/MM/YYYY); (DOI URL).

ISSN: 0277-786X

ISSN: 1996-756X (electronic)

ISBN: 9781510648999

ISBN: 9781510649002 (electronic)

Published by

SPIE

P.O. Box 10, Bellingham, Washington 98227-0010 USA

Telephone +1 360 676 3290 (Pacific Time)

SPIE.org

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